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APPLICANTS Masahiro Nakayama, Itami-shi, Hyogo, JAPAN; Naoki Matsumoto, Itami-shi, Hyogo, JAPAN;									
This applic ** FOREIGN APF JAPAN JP:	ation PLICA 20033	A ************************************		varified C	/infin	I A			
35 USC 119 (a-d) conditions yes no Met after COUNTRY DRA						EETS TOTAL CLAIMS		MS	INDEPENDENT CLAIMS 4
ADDRESS AIR MAIL 29453									
TITLE Gallium nitride se	mico	nductor substrate and	process 1	for producing t	he sam	e			
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